IN THE SPECIFICATION:

Please amend Page 2, Paragraph 0004 to read as follows:

However, such an effect is difficult to achieve in practice because, if eyestrain is to be eased using the apparatus, the subject must for a certain period do nothing but stare at the optotype charge inside the apparatus. Thus, it is difficult o have the subject continue using the apparatus in the long term. If, however, the subject is able to see his pupillary state changing between a state of mydriasis and one of miosis through his use of the apparatus, it is conceivable that such long-term use will be achieved. Methods to measure pupil size using for instance an apparatus which measures pupil size using a CMOS (Complementary Metal – Oxide Semiconductor) image sensor, have been developed ([[Seen]] See Patent Document 1), and it is theoretically possible that such techniques will be applied in fatigue recovery facilitating apparatuses.